

GUJARAT TECHNOLOGICAL UNIVERSITY**BE - SEMESTER- V (New) EXAMINATION – WINTER 2019****Subject Code: 2153901****Date: 25/11/2019****Subject Name: Fabrication of Nano- devices****Time: 10:30 AM TO 01:00 PM****Total Marks: 70****Instructions:**

1. Attempt all questions.
2. Make suitable assumptions wherever necessary.
3. Figures to the right indicate full marks.

MARKS

- | | | |
|------------|--|-----------|
| Q.1 | (a) Explain Core-Shell Structure. | 03 |
| | (b) Describe Atom Lithography. | 04 |
| | (c) Define Quantum Structures. Explain Its Size and Dimensionality Effect. | 07 |
| Q.2 | (a) Define Gas Sensor. | 03 |
| | (b) Describe Graphene and Fullerene. | 04 |
| | (c) Define Photonic Crystal and explain Photonic band Gap devices with Application. | 07 |
| | OR | |
| | (c) Describe Protein-Based Biosensor | 07 |
| Q.3 | (a) Explain Lithography. Mention Different types of Lithography. | 03 |
| | (b) Explain Different type of Gas Sensor Briefly. | 04 |
| | (c) Explain X-ray Lithography with Appropriate Diagram. | 07 |
| | OR | |
| Q.3 | (a) Describe Schottky Diodes and Schottky Barriers. | 03 |
| | (b) Define DNA Based Biosensor. | 04 |
| | (c) Write down full form of MOSFET, explain it briefly with Types(Diagram) | 07 |
| Q.4 | (a) Explain the Concept of Photochemical Molecular Devices. | 03 |
| | (b) Define Nanorods, Nanowire, Nanofibres and Nanotubes. | 04 |
| | (c) What are Nanocomputers? Explain its Fabrication Methods and Types. | 07 |
| | OR | |
| Q.4 | (a) Define Antibody and Antigens. | 03 |
| | (b) Describe Application by Function of Gas Sensors. | 04 |
| | (c) Explain the Concept of Single Electron Tunneling. | 07 |
| Q.5 | (a) Mention Any Five Single Electron Devices. | 03 |
| | (b) Describe Optical Fibers for Nanodevices. | 04 |
| | (c) Define Resonant Tunneling and hence explain Resonant tunneling Diode, Resonant Tunneling Transistor. | 07 |
| | OR | |
| Q.5 | (a) Explain Nano Robotics and Nano Manipulation. | 03 |
| | (b) Define Carbon Nanotube based Logic Gates. | 04 |
| | (c) Write a short note on Ion Lithography. | 07 |
